

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Grimbergen et al.	Group Art Unit: 1763
Application No: 09/595,778	Examiner: Alan W. Olsen
Confirmation No: 6490	Attorney Docket No:
Filed: June 16, 2000	002077 USA D01/ETCH/SILICON/JB1
Title: APPARATUS AND METHOD FOR MONITORING PROCESSING OF A SUBSTRATE	April 4, 2003 San Francisco, California

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4/8/03  
mW

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

Assistant Commissioner for Patents  
Washington, D.C. 20231

Via Facsimile Transmission  
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Examiner Olsen:

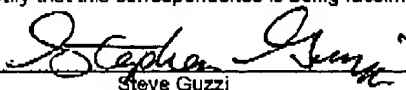
This communication is in response to the Office Action mailed on December 4, 2002, and is being filed within four months thereof with a request for a one month extension of time.

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Date 4/4/2003